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EE C247B - ME C218 Introduction to MEMS Design Spring 2015

Prof. Clark T.-C. Nguyen

Dept. of Electrical Engineering & Computer Sciences
University of California at Berkeley
Berkeley, CA 94720

<u>Lecture Module 9</u>: Energy Methods

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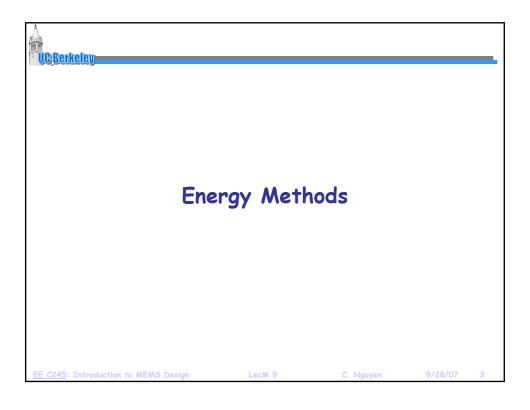
Lecture Outline

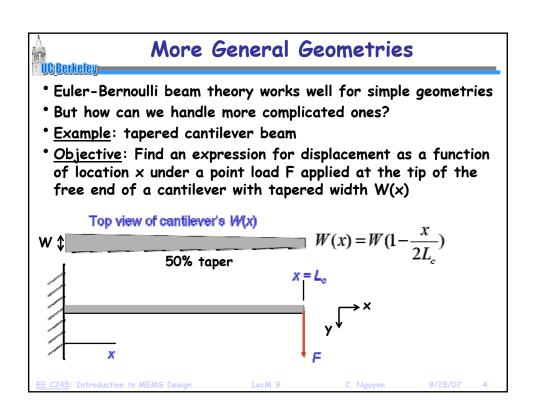
- Reading: Senturia, Chpt. 10
- Lecture Topics:
 - \$ Energy Methods
 - ◆ Virtual Work
 - Energy Formulations
 - ◆ Tapered Beam Example

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Solution: Use Principle of Virtual Work

- In an energy-conserving system (i.e., elastic materials), the energy stored in a body due to the quasi-static (i.e., slow) action of surface and body forces is equal to the work done by these forces ...
- <u>Implication</u>: if we can formulate <u>stored energy</u> as a function of the deformation of a mechanical object, then we can determine how an object responds to a force by determining the shape the object must take in order to <u>minimize</u> the <u>difference</u> U between the stored energy and the work done by the forces:

U = Stored Energy - Work Done

 Key idea: we don't have to reach U = 0 to produce a very useful, approximate analytical result for load-deflection

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More Visual Description ...

Same problem as before: Take a beam tapply a force:

(DApply force.
(3) Bean responds by bending.

(This force has done work:
(1) Strain generated -> This means the beam has received an influx of stored energy

(3) Then:

(3) Then:

(4) Strain generated -> This means the beam has received an influx of stored energy

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(4) Strain generated -> This means the beam has received an influx of stored energy

(3) Then:

(4) U = Stored Energy - Work Done -> O

(5) U = Stored Energy - Work Done -> O

(6) U = Stored Energy - Work Done -> O

(7) U = Stored Energy - Work Done -> O

(8) U = Stored Energy - Work Done -> O

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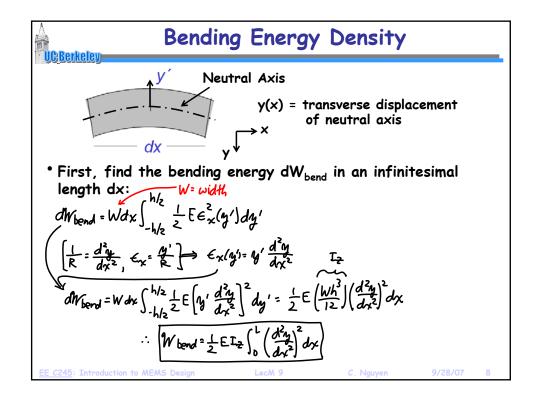
(9) U = Stored Energy - Work Done -> O

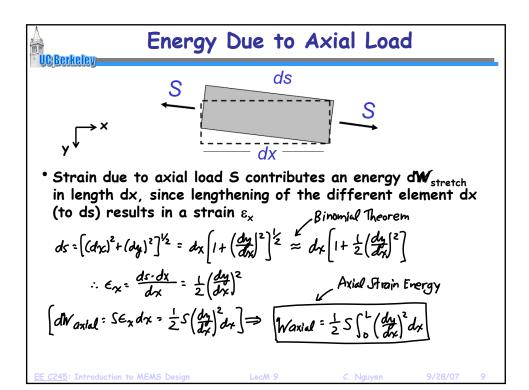
(9) U = Stored Energy - Work Done -> O

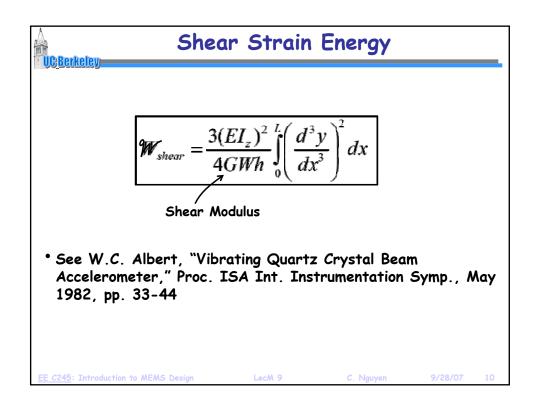
(9) U = Stored Energy - Work Done -> O

(9) U = Stored Energy -> U = Stored E

• Strain energy density:
$$[J/m^3]$$
 $W(0): \int_0^0 \frac{d}{c} da$ do the form of the work done in straining material street energy on a capacity the work densities, to find work done in straining material street energy on a capacity $W = \int_0^{\infty} \frac{d}{c} \frac{d}{dc} \frac{dc}{c} \frac{dc}{$

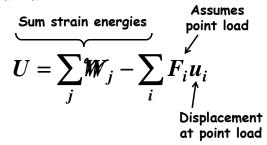






Applying the Principle of Virtual Work

- Basic Procedure:
 - Suess the form of the beam deflection under the applied loads
 - ♦ Vary the parameters in the beam deflection function in order to minimize:



- \$ Find minima by simply setting derivatives to zero
- See Senturia, pg. 244, for a general expression with distrubuted surface loads and body forces

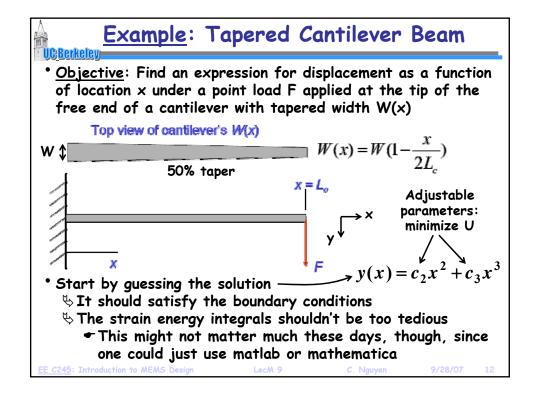
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Strain Energy And Work By F

$$U = W_{bend} - F \cdot y(L_e)$$

$$W_{bend} = \frac{1}{2} E \int_{0}^{L_e} I_z(x) \left(\frac{d^2 y}{dx^2} \right)^2 dx \qquad \text{(Bending Energy)}$$

$$I_z(x) = \frac{W(x)h^3}{12} \qquad \frac{d^2 y}{dx^2} = 2c_2 + 6c_3 x \qquad \text{(Using our guess)}$$

$$W(x) = W(1 - \frac{x}{2L_e}) \qquad \text{Tip Deflection}$$

$$= \frac{1}{24} EWh^3 \int_{0}^{L_e} (1 - \frac{x}{2L_e}) (2c_2 + 6c_3 x)^2 dx - F(c_2 L_e^2 + c_3 L_e^3)$$
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Find c_2 and c_3 That Minimize U

- Minimize U \rightarrow basically, find the c_2 and c_3 that brings U closest to zero (which is what it would be if we had guessed correctly)
- The c₂ and c₃ that minimize U are the ones for which the partial derivatives of U with respective to them are zero:

$$\frac{\partial U}{\partial c_2} = 0 \qquad \frac{\partial U}{\partial c_3} = 0$$

• Proceed:

 $\$ First, evaluate the integral to get an expression for U:

$$U = EWh^{3} \left\{ \frac{5c_{3}^{2}}{16} L_{c}^{3} + \frac{c_{2}c_{3}}{3} L_{c}^{2} + \frac{c_{2}^{2}}{8} L_{c} \right\} - F(c_{2}L_{c}^{2} + c_{3}L_{c}^{3})$$

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Minimize U (cont)

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• Evaluate the derivatives and set to zero:

$$\frac{\partial U}{\partial c_2} = 0 = \left(\frac{EWh^3}{3}c_3 - F\right)L_c^2 + \left(\frac{EWh^3}{4}c_2\right)L_c$$

$$\frac{\partial U}{\partial c_3} = 0 = \left(\frac{5}{8}EWh^3c_3 - F\right)L_c^3 + \left(\frac{EWh^3}{3}c_2\right)L_c^2$$

• Solve the simultaneous equations to get c_2 and c_3 :

$$c_2 = \left(\frac{84}{13}\right) \frac{FL_c}{EWh^3} \qquad c_3 = -\left(\frac{24}{13}\right) \frac{F}{EWh^3}$$

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The Virtual Work-Derived Solution

* And the solution:

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$$y(x) = \left(\frac{24F}{13EWh^3}\right) \left(\frac{7}{2}\right) L_c - x x^2$$

• Solve for tip deflection and obtain the spring constant:

$$y(L_c) = \left(\frac{24F}{13EWh^3}\right)\left(\frac{5}{2}\right)L_c^3$$
 $k_c = F/y(L_c) = \left(\frac{13EWh^3}{60L_c^3}\right)$

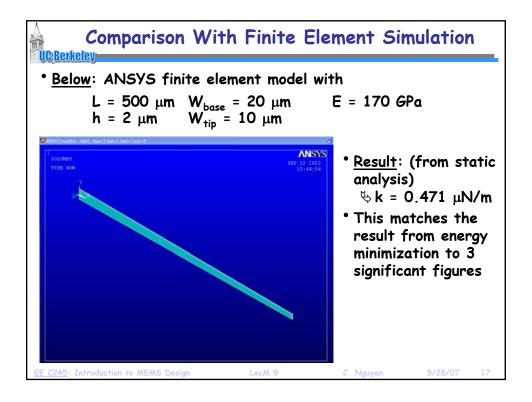
 Compare with previous solution for constant-width cantilever beam (using Euler theory):

$$y(L_c) = \left(\frac{4F}{EWh^3}\right)L_c^3 \longrightarrow 13\%$$
 smaller than tapered-width case

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Need a Better Approximation?

- Add more terms to the polynomial
- Add other strain energy terms:
 - ♦ Shear: more significant as the beam gets shorter
 - ♦ Axial: more significant as deflections become larger
- Both of the above remedies make the math more complex, so encourage the use of math software, such as Mathematica, Matlab, or Maple
- Finite element analysis is really just energy minimization
- If this is the case, then why ever use energy minimization analytically (i.e., by hand)?
 - Analytical expressions, even approximate ones, give insight into parameter dependencies that FEA cannot
 - Can compare the importance of different terms
 - Should use in tandem with FEA for design

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